



Docket No.: SON-3163
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tomiji Tanaka et al.

Application No.: 10/579,903

Confirmation No.: 6919

Filed: November 15, 2006

Art Unit: 2828

For: EXTERNAL CAVITY TYPE
SEMICONDUCTOR LASER

Examiner: Michael W. Carter

AMENDMENT SUBMITTED WITH REQUEST FOR CONTINUED EXAMINATION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated June 4, 2008, and in conjunction with the Request for Continued Examination concurrently filed herewith, Applicant respectfully requests reconsideration of the above-identified U.S. patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.